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APPLN. OF: ZHANG  
SERIAL NO.: 09/739,477  
FILED: DECEMBER 18, 2000  
FOR: METHOD OF PROCESSING A NANOTUBE  
GROUP: 1772  
DOCKET: NEC PF-2727

**Match & Return**

Assistant Commissioner for Patents  
Washington, D.C. 20231

**SUBMISSION OF PRIORITY DOCUMENT and**  
**INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

Submitted herewith is a certified copy of Japanese Patent Application No.11-359579 in support of Applicants' priority claim under 35 USC 119.

In connection with the above-entitled matter, Applicant hereby attaches U.S. Patent Office Form PTOL-1449, including copies of the prior art references listed therein. These references are discussed in the specification. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitute prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

We believe there are no fees involved with this submission. However, in the event there



are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,

Norman P. Soloway  
Attorney for Applicant  
Reg. No. 24,315

clm

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on March 22, 2001 at Manchester, New Hampshire.

By: Carol McOlland